

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Den Toonder, *et al.*

Docket No.: EPC-018

Serial No.: 10/578,027

Examiner: TBD

Filed: April 27, 2006

Art Unit: TBD

For: Radio-Frequency Microelectromechanical Systems and a Method of Manufacturing Such Systems

Commissioner for Patents  
P. O. Box 1450  
Alexandria, VA 22313-1450

## **INFORMATION DISCLOSURE STATEMENT**

Dear Sir:

The Applicants wish to bring to the attention of the Patent and Trademark Office the information noted on the enclosed form PTO/SB/08a that may be considered material to the examination of the above-identified application. Copies of the U.S. Patent and Publications cited are not being submitted. However, Applicants have included copies of the foreign patents.

No fee is due at this time, as this Information Disclosure Statement is being filed pursuant to 37 C.F.R. § 1.97(b)(3), before the mailing of a first Office Action on the merits.

Respectfully submitted,

8/21/08

Date \_\_\_\_\_

Ira S. Matsil  
Attorney for Applicants  
Reg. No. 35,272

Slater & Matsil, L.L.P.  
17950 Preston Rd., Suite 1000  
Dallas, TX 75252  
(972) 732-1001 (phone)  
(972) 732-9218 (fax)